

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No.	:	10/598,502	Confirmation No. 6549
Applicant	:	Yuichiro Nakamura et al.	
371 Filed	:	September 1, 2006	
Art Unit	:	1793	
Examiner	:	Mark L. Shevin	
Customer No.	:	00270	
Title	:	SPUTTERING TARGET WITH FEW SURFACE DEFECTS, AND SURFACE PROCESSING METHOD THEREOF	

Mail Stop RCE  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT**

Sir:

This is an Amendment submitted with a Request for Continued Examination filed in response to a FINAL Office Action dated June 3, 2009. A Petition for a One Month Extension of Time is being filed herewith to extend the deadline for response from September 3, 2009 to October 5, 2009 (October 5, 2009 being the first weekday following Saturday, October 3, 2009). Kindly amend the application as set forth below.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 6 of this paper.